



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor(s): Akira NAKASHIMA et al. : Confirmation No. 4777

U.S. Patent Application No. 10/533,302 : Group Art Unit: 1762

Filed: April 29, 2005 : Examiner:

For: COATING LIQUID FOR FORMING AMORPHOUS SILICA-BASED COATING

FILM WITH LOW DIELECTRIC CONSTANT AND METHOD FOR PREPARING

THE SAME

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Submitted herewith are Information Disclosure Statement and four references.

Please consider the information disclosure statement.

Respectfully submitted,

KANESAKA BERNER & PARTNERS

Manabu Kanesaka Registration No. 31,467

1700 Diagonal Road, Suite 310 Alexandria, Virginia 22314 (703) 519-9785 MAN/yok Facsimile: (703) 519-7769

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INFORMATION DISCLOSURE CITATION IN AN **APPLICATION** JAN 1 8 2007

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(PTO-1449)

U.S. PATENT ATTY. DOCKET NO. APPLICATION NO. **IPA-007** 10/533,302 **APPLICANT** Akira NAKASHIMA et al FILING DATE

GROUP

June 16, 2005

1762 U.S. PATENT DOCUMENTS FILING **EXAMINER'S** NAME **CLASS SUBCLASS** DATE PATENT NO. DATE INITIALS FOREIGN PATENT DOCUMENTS w.a. bear i Translation **EXAMINER'S CLASS SUBCLASS** COUNTRY PATENT NO. DATE Yes No INITIALS \mathbf{X} 06/24/1987 Europe EP 0 226 208 \mathbf{X} 10/17/2001 Europe EP 1 146 092 X Europe EP 1 142 832 10/10/2001 X 04/17/2002 EP 1 197 999 Europe OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) DATE CONSIDERED **EXAMINER**

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.